

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of		)
		)
	Tetsuro Inui et al.	)
		)
Serial No.:	10/624,082	) Art Unit
		) 4181
Filing Date:	July 21, 2003	)
		)
Confirmation No.:	5995	)
		)
For:	DISPERSION MONITORING METHOD AND	)
	APPARATUS AND DISPERSION SLOPE	)
	TEMPERATURE DEPENDENCY COMPENSATION	)
	METHOD AND APPARATUS	)
		)
Examiner:	Hibret Asnake Woldekidan	)

AMENDMENT "A" AND RESPONSE TO OFFICE ACTION

Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

Examiner:

Applicant submits this paper in response to the Office Action mailed February 6, 2008.

Reconsideration is respectfully requested in view of the following remarks:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Claims** begin on page 3 of this paper.

**Remarks** begin on page 8 of this paper.